



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Appln. Of: SAMUKAWA et al.  
Serial No.: 10/501,351  
Filed: July 14, 2004  
For: On-Wafer Monitoring System  
Group: 1763 Confirmation No. 7535  
EXAMINER: Dhingra, Rakesh Kumar DOCKET: SHIG CPTA0502FE

MAIL STOP RCE  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**AMENDMENT C WITH**  
**REQUEST FOR CONTINUED EXAMINATION (RCE)**

Dear Sir:

This Amendment is being filed in response to the Final Action mailed August 31, 2007.

A Request for Continued Examination (RCE) accompanies this Amendment.

Please amend the Application as follows:

**Amendments to the Claims** begin on page 2 of this Amendment.

**Remarks/Arguments** begin on page 5 of this Amendment.

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